

#### ASX / Media Release

#### Presentation to Stocks Down Under Semiconductor Conference

Fremont, California and Sydney, Australia; 17 November 2020 Pivotal Systems Corporation ("Pivotal" or the "Company") (ASX: PVS), a leading provider of innovative gas flow control ("GFC") solutions to the semiconductor industry, today provides the attached presentation, which is being presented by Mr. John Hoffman, Chairman and CEO of Pivotal at 10.30am AEDT today (3.30pm PST on Monday 16 November 2020). Investors should note this represents a late change from the conference organisers from 10.50am AEDT as previously announced to ASX on 13 November 2020.

Shareholders can register for the Virtual Conference at the following link: https://bakermckenzie.zoom.us/webinar/register/WN 7u 1yQb5TF2fCqqyinZRFw

A copy of the webcast will be available on the Company's website following the conference at: https://www.pivotalsys.com/investors/#presentations

- ENDS -

THIS RELEASE DATED 17 NOVEMBER 2020 HAS BEEN AUTHORISED FOR LODGEMENT TO ASX BY JOHN HOFFMAN, CHAIRMAN & CEO OF PIVOTAL SYSTEMS.

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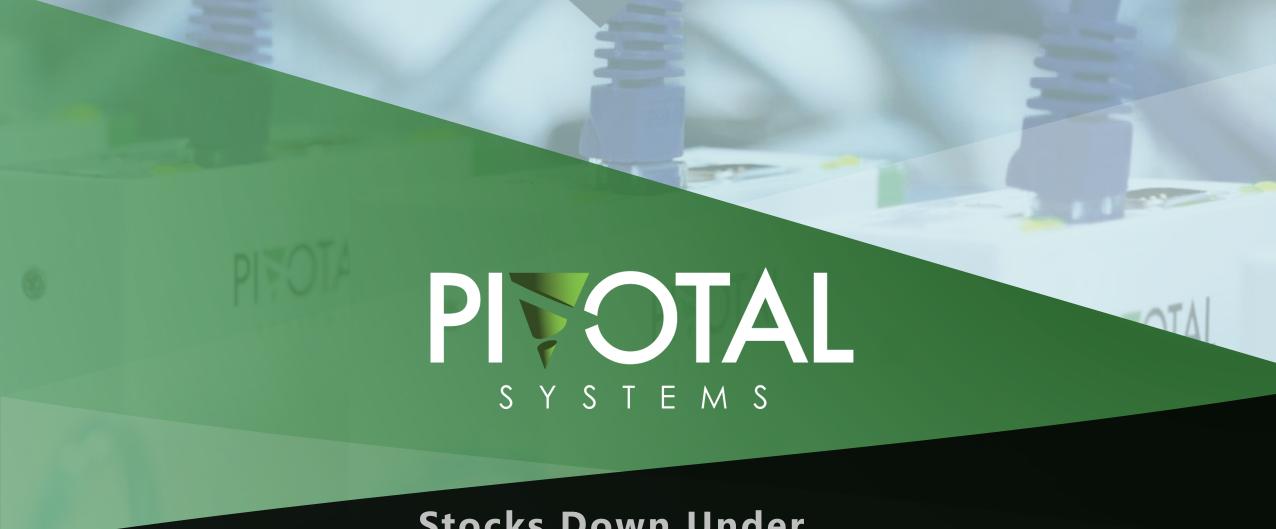
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#### About Pivotal Systems Corporation (ASX: PVS)

Pivotal Systems provides the best-in-class gas flow monitoring and control technology platform for the global semiconductor industry. The company's proprietary hardware and software utilizes advanced machine learning to enable preventative diagnostic capability resulting in an order of magnitude increase in fab productivity and capital efficiency for existing and future technology nodes. Pivotal Systems Corporation (ARBN 626 346 325), is a company incorporated in Delaware, USA, whose stockholders have limited liability.

If investors wish to subscribe to Pivotal Systems' email alert service for ASX Announcements, please follow this <u>link</u>.



Stocks Down Under Semiconductor Virtual Conference 17 November 2020 John Hoffman- Chairman & CEO

(ASX: PVS)

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Financial data - All dollar values are in US dollars (US\$) unless as otherwise presented.

#### Non IFRS financial measures

Pivotal Systems uses certain measures to manage and report on its business that are not recognised under Australian Accounting Standards or IFRS. These measures are collectively referred to in this document as 'non-IFRS financial measures' under Regulatory Guide 230 'Disclosing non-IFRS financial information' published by the Australian Securities and Investments Commission (ASIC). Management uses these non-IFRS financial measures to evaluate the performance and profitability of the overall business. The principal non-IFRS financial measures that are referred to in this document is EBITDA. EBITDA is earnings before interest, tax, depreciation and amortisation and significant items. Management uses EBITDA to evaluate the operating performance of the business prior to the impact of significant items, the non-cash impact of depreciation and amortisation and interest and tax charges.

Although Pivotal Systems believes that these measures provide useful information about the financial performance of Pivotal Systems, they should be considered as supplements to the income statement measures that have been presented in accordance with the Australia Accounting Standards and IFRS and not as a replacement for them.

#### PIVOTAL SYSTEMS SNAPSHOT

Pivotal Systems (Pivotal) designs, develops, manufactures and sells high quality and performance gas-flow controllers for both device manufacturers and equipment companies participating in the semiconductor capital equipment market

ASX Ticker	PVS	
GICS¹ Code	4530 (Semiconductor Equipment)	
Share Price (as at 10 November 2020)	\$0.86	
52 week low / high	\$0.71 / \$1.71	
Market Capitalisation <sup>2</sup>	\$98.0 million	
Cash on hand <sup>3</sup>	US\$6.2 million	
NTA per share <sup>3</sup>	US\$0.14	
Top 20 CDI⁴ Shareholders	83.2%	





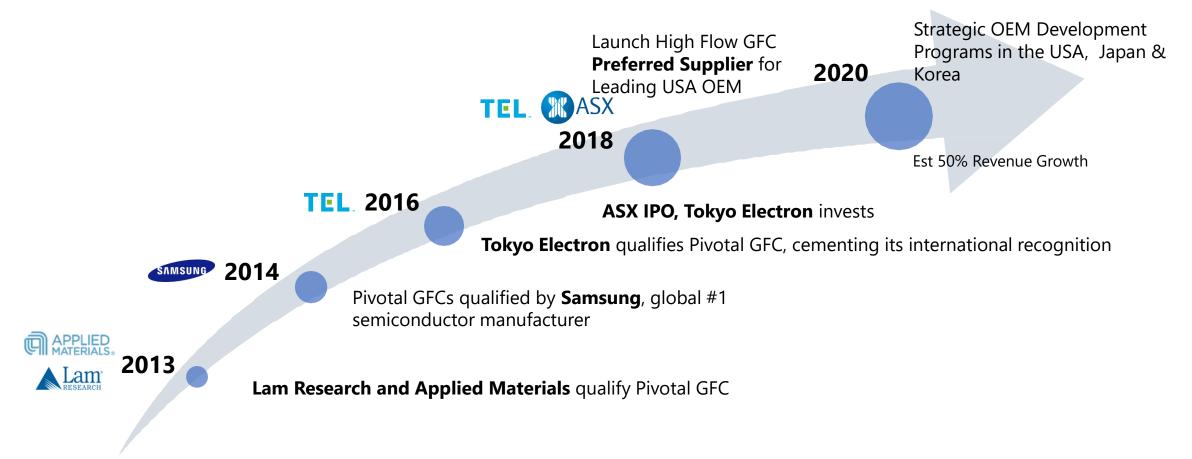






<sup>&</sup>lt;sup>4</sup> CDI – Chess Depository Interests (1:1 ratio with common stock)

# PIVOTAL HAS BEEN DEVELOPING AND MARKETING NEXT-GEN GAS FLOW CONTROLLERS FOR A DECADE, ENABLING ADVANCES IN SEMICONDUCTOR ETCHING & DEPOSITION



2011

Pivotal envisions that next-gen GFCs will be essential for the semiconductor industry <u>Core architecture</u> developed; key patents filed

#### **GLOBAL FOOTPRINT**

#### PIVOTAL HAS A MANUFACTURING AND SALES AND TECHNICAL SUPPORT PRESENCE ACROSS THE US, EUROPE AND ASIA



Pivotal technical, sales and distributor support



Pivotal Corporate HQ & R&D Center, Flex Capacity
As Required

- Production Partnerships in Korea and China
- Korea Upgrade & Service Center
- R&D partnerships in US and Japan
- Support in all key IC markets globally

All software development and R&D is conducted and securely held in Pivotal's headquarters in Fremont, California.

#### MARKET OPPORTUNITY

#### Flow controller manufacturers

- Manufacturers of gas flow control devices
- Industry participants include:
  - Horiba, Ltd.
  - **Brooks Instruments**
  - Fujikin
  - Hitachi Metals





Source: Pivotal analysis based on public filings, market reports, Statista. TAM – total addressable market.

#### **Original Equipment Manufacturers (OEMs)**

- Designers and manufacturers of process tools used in the production of semiconductors
- Industry participants include:









2020 EST. GFC DEMAND (OEM NEW TOOL)

**PVS GFCs are designed into OEM** semiconductor processing tools sold to IDMs for use in FAB plants (95% of TAM)

384,625 Units @ ASP of \$1.200\*

3.2%

\$461M TAM by Value

\$485M MFC TOTAL ADDRESSABLE MARKET IN 2020

8% Est. 2020 growth

**PIVOTAL IMPLIED PENETRATION @ 2019 REVENUES** 

19,875

\$24M TAM by Value

8% Est. 2020 growth

#### **Integrated Device Manufacturers (IDMs)**

- Semiconductor and integrated device manufacturers
- A sample of industry participants include:









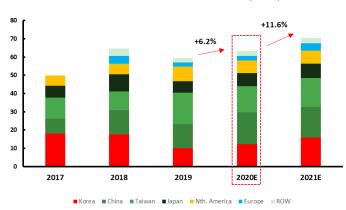
2020 EST. GFC DEMAND (IDM / RETROFIT)

Retrofits are approximately 5% of TAM and **Driven by OPEX Spending at FAB Level** 

Units @ ASP of \$1.200\*

**SEMICONDUCTOR CAPITAL EQUIPMENT** MARKET FORECAST TO GROW 8% IN 2020 & 15% in 2021, DESPITE COVID-19

TOTAL SEMICONDUCTOR EQUIPMENT MARKET (US\$Bn)1



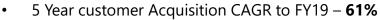
Forecast 2020 global semiconductor equipment sales of US\$63.2Bn with wafer fabrication equipment (WFE) up 8%

Forecast 2021 global semiconductor equipment sales reaching over US\$70Bn driven by WFE up 15% (All time record)

Growth trajectory driven by advanced logic/foundry (single digit growth) and the memory market (DRAM, NAND) spending with growth over 20% in 2021

#### CUSTOMER EXPANSION & BUILDING DURABLE BARRIERS TO **ENTRY**

#### **Global Customer Base Customer Stratified by Type** ■ OEM 2014 2015 2016 2017 2018 2019 1H2020 2017 2019 1H2020 Other (Inc. Research Universities, HDD, Flat Panel & Solar)



- Continued Momentum in 2020
- Multiple OEM Development Programs
- Continuous Innovation and Customer Acceptance
- PVS Now viewed as the "Go To" Technology Leader

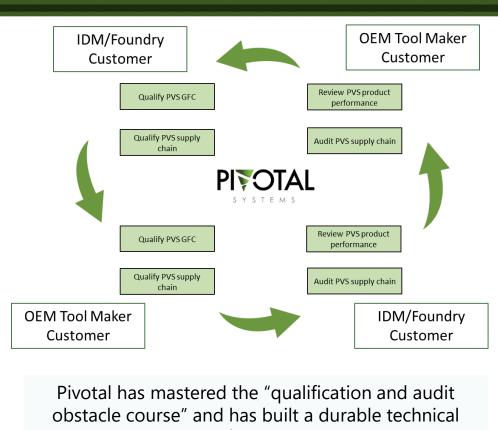


2017

2018

2019

1H2020



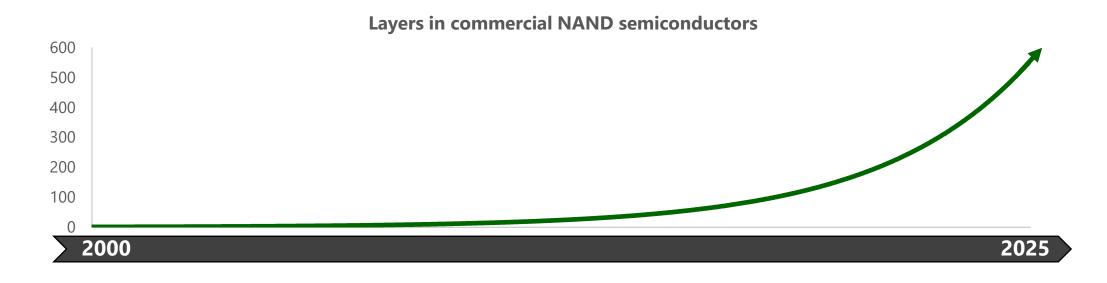
advantage

ISO 9001:2015 Re- Certified Large, Multi-Billion Dollar Customers Multiple Successful OEM / IDM 36 Qualified Customers to Date **Operational Audits Completed** 



<sup>2.</sup> Customers who are currently Validatina the Pivotal GFC Technology.

## WHAT'S THE PROBLEM? GAS FLOW CONTROL INNOVATION HAS LAGGED BEHIND, WITH OUTDATED TECHNOLOGY PLATFORMS—UNTIL PIVOTAL SYSTEMS LAUNCHED



#### **Thermal-based Flow Control Platforms**



#### **Pressure-based Flow Control Platforms**



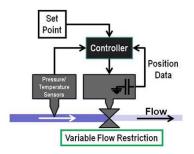






# PIVOTAL'S POSITIVE POSITIONAL CONTROL TECHNOLOGY ENABLES MUCH HIGHER SPEEDS, BETTER ACCURACY, AND DYNAMIC FLOW SHAPING, RENDERING OTHER PLATFORMS OBSOLETE

#### **Positive Positional Control GFC**



**Technology** Direct real-time control of valve position at all times

Key physical performance limitations

Elimination of buildup enables near instantaneous response

10 milliseconds

None

Typical Response Speed

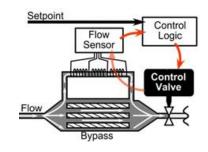
Verifiable Accuracy

Dynamic Flow Shaping

**Accurate to ±0.5%** with continuous real time verification

**Yes;** dynamic ability to shape the gas flow throughout the cycle

#### Thermal-based MFC



Metal tube, heater, thermometer to measure flow

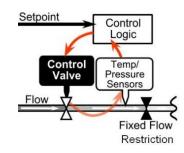
Buildup of temperature inherently limits speed

1000 milliseconds

No verification or correction possible; with inherent drift

None

#### **Pressure-based MFC**



Control of pressure upstream of a flow restrictor to control flow

Buildup of pressure inherently limits speed

500-800 milliseconds

No correction possible, limited verification

None

# PIVOTAL NOW HAS A WIDE RANGE OF PRODUCTS BASED UPON THE POSITIVE POSITIONAL CONTROL TECHNOLOGY

**Gas Flow Controllers** 

	PROTAL PR	PROTAL PR	PINOTAL
Application	Etch	Deposition	Etch and Deposition
Specs	Wide Flow Range: 0.5-100% Full Scale  Best Flow Accuracy: ±0.5% of Setpoint  Fastest On/Off Settling Time:  10%-100% FS ≤ 100ms  0.5%-10% FS ≤ 300ms	<ul> <li>Wide Flow Range: 2.0-100% Full Scale</li> <li>Flow Accuracy:         <ul> <li>±1.0% of Setpoint 0.5slm – 5slm, 2.0slm – 20slm, 5.0slm – 50slm</li> <li>±0.25% of full scale for 2.0-10.0% Full Scale</li> </ul> </li> <li>Fastest On/Off Settling Time:         <ul> <li>10%-100% FS ≤ 100ms</li> <li>0.5%-10% FS ≤ 300ms</li> </ul> </li> </ul>	Flow Range: 30L per channel Number of Channels:  • 2-8 Flow Accuracy:  • ±0.5% of set point Set Point Change Settling Time:  • <100ms Flow Change Settling Time:  • <500m
Model numbers	GFC5™   GFC20™   GFC200™   GFC1000™   GFC2000™	GFC5L™   GFC20L™   GFC50L™	PPC 30L

**High Flow Gas Flow Controllers** 

**Flow Ratio Controller** 

Pivotal product line covers all aspects of industry needs

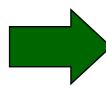


#### SPEED MATTERS: ILLUSTRATION OF FASTER PIVOTAL GFC'S DELIVERING MORE FAB OUTPUT



0.5% accuracy On: 50 msec

Off: 50 msec



Example: Pivotal's faster GFC technology translates to 16%+ more wafers on bottleneck tools

while improving production output (Yield)

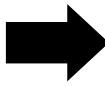
#### **Competitor Solutions**



1% accuracy

On: ±500 msec

Off: Up to 1 second





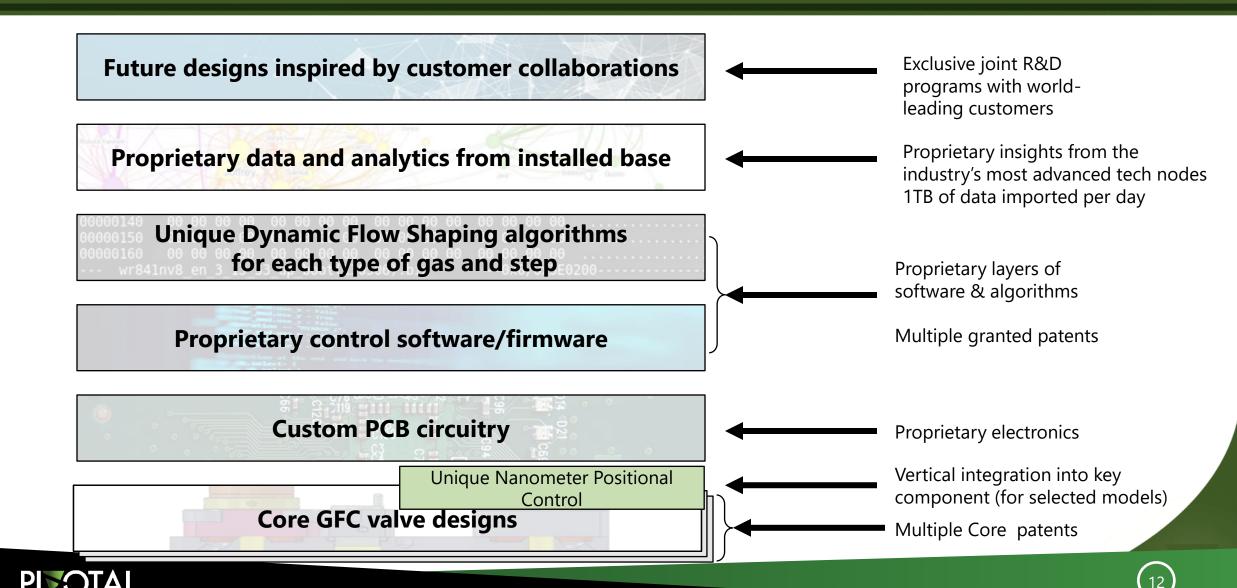
**Typical OEM 3-**

**Chamber Process** 

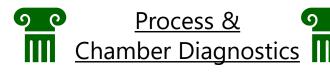
Tool

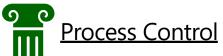
1: Assume 10 Sec Etch Process: Pivotal Provides 9.9 sec of Production; Competitor 8.5 sec of Production

#### Pivotal's Positive Positional Control Technology: several proprietary layers



#### PIVOTAL'S POSITIVE POSITIONAL CONTROL TECHNOLOGY: HIGHLY PATENT-PROTECTED







<u>Fab/Tool/Network</u> <u>Communications</u>



Gas Flow Measurement & Control

#### Pivotal holds a total of <u>36 Patents</u> and <u>389 Claims</u>

#### **GFC WITH PRESSURE REGULATOR**

US 7,823,436 November 2010

#### PIVOTAL GFC SYSTEM WITH IN- SITU FLOW CORRECTION

US 8,240,324 August 2012

#### **GFC WITH DATA EXCLUSION**

US 8,271,211 September 2012

#### **GFC WITH DERIVED TIMESTAMP**

US 8,265,888 September 2012

#### GFC WITH ANALOG AND DIGITAL NORMALIZATION

US 8,271,210 September 2012

#### INSITU TESTING OF GAS FLOW CONTROLLERS

US 8,667,830 March 2014

#### **GFC DRIFT MEASUREMENT**

US 8,857,456 October 2014

#### **INSITU VOLUME MEASUREMENT**

US 8,857,456 October 2014

#### TRANSIENT MEASUREMENT OF MFC

US 9,400,004 July 2016

#### **GFC WITH DISPLACEMENT SENSOR**

US 9,523,435 December 2016

#### **ACTUATOR CONTROLLED GFC**

US 9,904,297 February 2018

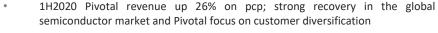
#### ACTUATOR GFC WITH LOOKUP TABLE

US 10,401,202 September 2019



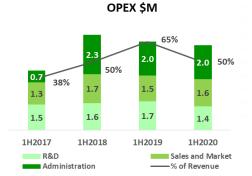
#### KEY FINANCIAL METRICS



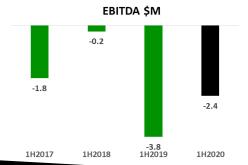


#### New orders were up 553% versus the prior corresponding period (pcp) and represents 142% of the entire new orders achieved in FY2019, where industry downturn was significant

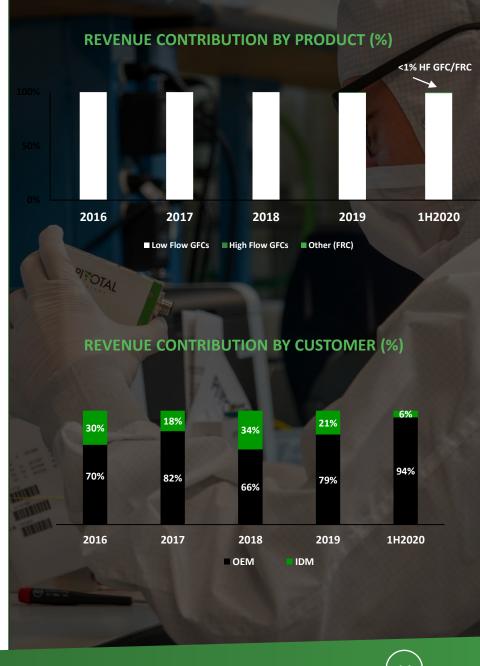
- Product diversification (>99% revenues for etch (low flow GFCs) applications), now building momentum in deposition (high flow GFCs) – 1% revenue in 1H2020, significant opportunity for growth
- Pivotal to capitalize on the strength of growth in the semiconductor industry in 2H 2020 and 2021



- OPEX in 1H 2020 represented 50% sales versus 65% in the pcp
- 1H2020 Proforma GPM of 18.9%, after adjusting substantially for US Customs Duty (reported margin of 1.5%)
- 2021 Steady state gross margins expected to be in the 30-40% range



- 1H2020 EBITDA loss improvement of 37%, driven by strong revenue growth and lower operating expenditures.
- 2H2020 Korean CM Activation Eliminates China USA Duty
- Business has exceptional operating leverage potential
- Improving GPM from 2H2020 onwards





#### GROWTH STRATEGIES



WFE sector growing. Etch and deposition are fastest-growing segments of WFE



Growing installed base of Pivotal GFCs drives recurring revenue streams



Market share gains and margins are growing, as Pivotal move from qualified to preferred to exclusive

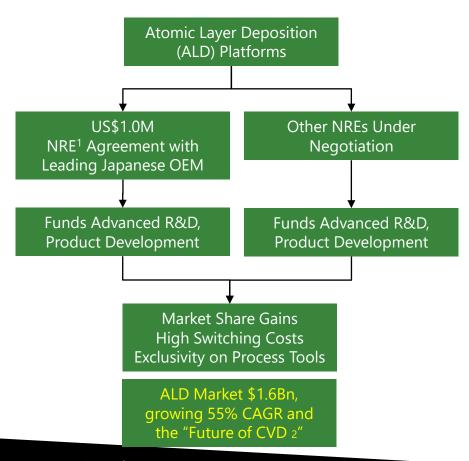


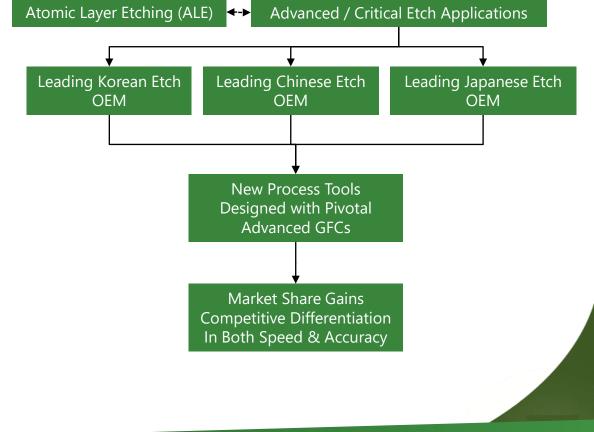
SAM is growing as Pivotal expands product portfolio across the WFE value chain

WFE – wafer fabrication equipment; SAM - \$68Bn in 2020 up 6% according to SEMI in July 2020 Report

# HIGH SWITCHING COSTS AND BARRIERS TO ENTRY FOR NEXT GENERATION TOOLS = SUSTAINABLE COMPETITIVE ADVANTAGE

Pivotal Has OEM-Lead Integration Programs in Place for both Leading-Edge Deposition and Etch Platforms





- NRE- Non-Recurring Engineering
- 2. Lam Investor Day Presentation July 2020



#### 2020 OUTLOOK

# SIGNIFICANTLY IMPROVED SEMICONDUCTOR MARKET OUTLOOK FOR REMAINDER OF 2020 & STRONGER GROWTH IN 2021

- Most recent expectations are for overall industry growth of **8%** in 2020 and **15%** in 2021.
- Forecast 2020 global semiconductor equipment sales of US\$63.2Bn with wafer fabrication equipment (WFE).
- According to SEMI, memory market (DRAM, NAND) expected to grow 16% in 2020 and accelerate further to 18% (Blended) growth in 2021.

### PIVOTAL EXPECTS SEQUENTIAL REVENUE GROWTH IN 2H2020

- Company sees continued strengthening in the overall semiconductor industry into 2021, where industry growth is anticipated to achieve record levels.
- The Company anticipates that 2H2020 revenues will increase sequentially on the first half (\$10.1M) with Q3 2020 Revenues of \$5.9M announced in recent 4C Commentary.
- Pivotal maintains that its client-led new product development efforts are the key catalyst for future market share gains.

#### PIVOTAL'S LEADERSHIP TEAM



John Hoffman
Chief Executive Officer

- >30 years of global high technology management experience
- 18 years at Applied Materials, Corporate Officer
- B.S., United States
   Military Academy at West
   Point and an Executive
   MBA (AEA), Stanford
   University



Joe Monkowski Ph.D Chief Technical Officer

- Founder of Pivotal Systems
- Extensive experience in the semiconductor industry focused on providing process equipment and metrology solutions
- Former CTO of Lam
   Research



<u>Dennis Mahoney</u> Chief Financial Officer

- >30 years of experience, across public/private co., raising equity and debt, global M&A
- Former VP Finance, CFO and Corporate Secretary of ADAC Laboratories
- M.B.A from the Haas School of Business UC at Berkeley and a B.S. also from UC Berkeley



Kevin Hill
Chief Operating Officer

- >25 years of global high technology management experience
- Former Apple New Product Operations
- B.S., United States
   Military Academy at
   West Point, MSBA
   Boston University, and
   Certified Product
   Manager



Kelly McDonough

VP Engineering

- Former engineer at Applied Materials
- B.S., Mechanical Engineering, Notre Dame and MSME, Mechanical Engineering, U. Wash.



Adam Goler Ph.D
Research & Development

- Graduate research emphasis on molecular dynamics simulation, and super resolution fluorescence microscopy
- Ph.D, Physics,
   Washington State
   University, B.S., Physics
   and Mathematics,
   American University



Nori Kobayakawa
VP Sales and Marketing

- >20 years experience in Asian markets driving increased market share and revenue
- Former Business
   Development Executive
   at KLA-Tencor















Collectively decades of experience across the semiconductor value chain





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